Origin and optimization of large dark current increase in InGaAs/InP APD

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Abstract- Dark current of our InGaAs/InP planar SAGCM APD is simulated. Activation energy $E_a$ obtained from the I-V test under temperature range of 240K~300K is cooperated in the simulation. Two origins of the dark current increase of over one order of magnitude from the punchthrouth voltage to the breakthrough voltage are analyzed. Our results provide two critical points to reduce the dark current of an InGaAs/InP APD operated under the linear operation mode.

I. INTRODUCTION

In Avalanche Photodiode infrared detectors (APDs), dark current under linear mode has a critical influence on their dark count rate and after pulse characteristics [¹]. In our APDs, we observe a dark current increase of over one order of magnitude from the punchthrough voltage ($V_p$) to the breakthrough voltage ($V_b$), which has serious affect on the device performance. In this paper, we provide analysis of origins of the dark current increase. Simulation results of $I_{TAT}$ caused by InP multiplication layer trap and $I_{GR}$ caused by InGaAs absorption layer deep level trap according to I-V experiment results under different temperatures reveal that reduction of traps in InP multiplication layer and InGaAs absorption layer and proper optimization of InP charge layer are the critical points to reduce the unexpected dark current.

II. SIMULATION RESULTS

Device A, a typical one of our InGaAs/InP planar SAGCM APD, is the device simulated below. Device B is a comparison device with good dark current characteristics. Fig.1 shows the I-V characteristics of device A and B test results conducted using Keithley 4200. In Fig. 1, we can clearly see the problem of dark current increasing by about two orders of magnitude from $V_p$ to $V_b$. The simulations below are aimed at analyzing this problem.

![Graph of I-V characteristics of device A and B](image1)

Fig. 1 Experimental I-V characteristics of device A and B

The simulation is conducted in a two dimensional way without the consideration of Guard Ring for simplicity. We solve the coupled Poisson Equation with the Carrier Continuity Equation while components of diffusion current $I_{diff}$, thermal generation-recombination($GR$) current $I_{GR}$, trap-assisted tunneling($TAT$) current $I_{TAT}$, direct radiative combination current $I_{Radiative}$, band to band($B2B$) tunneling current $I_{B2B}$ and Auger recombination current $I_{Auger}$ are taken into consideration.

According to the activation energy $E_a$ obtained from the I-V test under temperature range of 240K~300K [²], $E_a$ is at about 0.25$E_g$ of the InP band gap, far away from the mid-band gap. With a high electric field located in the InP multiplication layer, the $I_{TAT}$ overweighs $I_{GR}$ to be the main component of the current resulted from InP multiplication layer traps. Fig. 2 displays the simulated current originated from InP multiplication layer trap and its components ($I_{diff}$ and $I_{Auger}$ are not denoted for they are
too small compared to the denoted ones). From Fig. 2 we can see that the TAT current and GR current match our analysis above, with the proportion of TAT rises with bias voltage approaching Vb where Electric Field is high. Trap level is set to 0.44eV away from the mid-band gap according to the value of fitted activation energy Ea. carrier life time is set to 10 μs according to an experience value of 0.1 μs ~ 100 μs[1].

The total current originated from InP multiplication layer trap results in an increase of dark current from the Vp to Vb by over one order of magnitude. However, inset shows that this current is not enough for increasing of dark current. So with the analysis of the current step at Vp, we will provide another origin that contributes to the dark current increase.

Simulation results show that with the increase of trap level deviation from mid-band gap, current step gets lower with an exponential decrease. For the trap concentration of 1 × 10¹⁴ cm⁻³, the current reduces by two orders of magnitude when trap level deviation from mid-band gap varies from 0eV to 0.1eV.

Our fitting data shows that the deviation of Ea from InGaAs mid-band gap (0.75/2 = 0.375eV) varies from 0.005eV to 0.1eV and Ea vs Vbias curve displays linear decreasing characteristic. If we simplify Ea into a minority deep trap level in the InGaAs band gap, the trap level approaches mid-band gap with the bending of energy band which results in an exponential increase of thermal GR current. With trap concentration remaining the same, the current shows over one order magnitude from Vp to Vb (denoted in red dashed line in Fig. 3). A steeper slope of Trap Level vs. Vbias curve is related with higher electric field intensity in the InGaAs absorption layer. This suggests a much more proper InGaAs absorption layer electric field adjustment be made by optimizing InP charge layer.

III. CONCLUSIONS

We provided two origins resulting unexpected dark current increase of nearly two orders of magnitude, I_TAT caused by InP multiplication layer trap and I_GR caused by InGaAs absorption layer deep level trap. Based on the results, we brought up corresponding optimization methods, which include reducing traps in InP multiplication layer and InGaAs absorption layer and reconsidering InP charge layer design on its effect of adjusting InGaAs absorption layer electric field.

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